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**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 3729**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hajime AMANO et al.

Group Art Unit: 3729

Application No.: 09/818,565

Examiner: P. Kim

Filed: March 28, 2001

Docket No.: 109102

For: METHOD OF MANUFACTURING SPIN VALVE FILM

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the October 25, 2004 Office Action, and further to a January 25, 2005  
telephonic interview with Examiner Kim, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and  
**Remarks.**